



INFORMATION DISCLOSURE STATEMENT BY APPLICANT  Sheet 1 of 1	Application Number:	10/646,467
	Filing Date:	August 22, 2003
	First Named Inventor:	Kenneth COLLINS, et al.
	Group Art Unit:	<del>Unknown</del> 2812
	Examiner Name:	<del>Unknown</del> GHYKA
Attorney Docket Number:		6915 P06

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Examiner's Signature:

*AG*

Date Considered:

7/7/07

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.